

Accepted Manuscript

Title: Very High Photoresponse towards Low-Powered UV Light under Low-Biased Condition by Nanocrystal Assembled TiO₂ Film

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PII: S0169-4332(17)32360-7
DOI: <http://dx.doi.org/10.1016/j.apsusc.2017.08.037>
Reference: APSUSC 36874

To appear in: *APSUSC*

Received date: 1-5-2017
Revised date: 27-7-2017
Accepted date: 4-8-2017

Please cite this article as: Sulakshana Mondal, Durga Basak, Very High Photoresponse towards Low-Powered UV Light under Low-Biased Condition by Nanocrystal Assembled TiO₂ Film, Applied Surface Science <http://dx.doi.org/10.1016/j.apsusc.2017.08.037>

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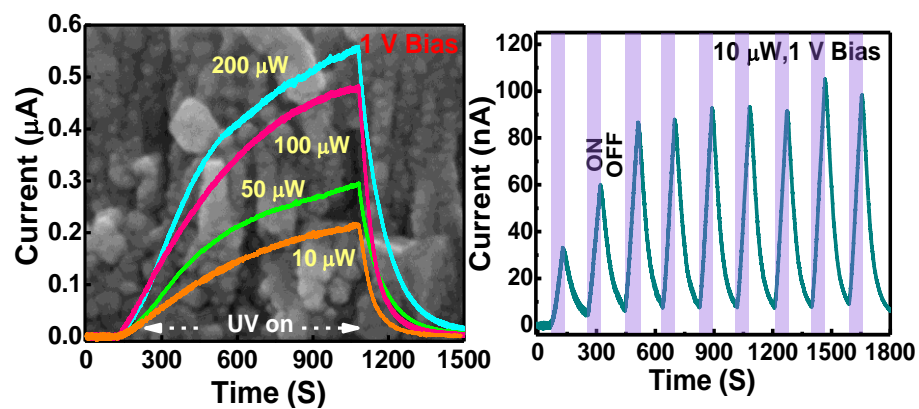
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Graphical abstract



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